Docket No.: OGOSH43USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.

10/565,767

Confirmation No. 2990

Applicant

: Yuichiro Shindo

371 Filed

January 24, 2006

Art Unit

1793

Examiner

Mark L. Shevin

Customer No.

00270

Title

HIGHLY PURE HAFNIUM MATERIAL, TARGET AND THIN

FILM COMPRSING THE SAME, AND METHOD FOR

PRODUCING HIGHLY PURE HAFNIUM

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is a timely filed Amendment in response to the non-final Office Action dated March 10, 2008. Kindly amend the application as set forth below.

<u>Amendments to the Claims</u> are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.